

 <p style="text-align: center;">INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)</p>	Docket Number (Optional) 15689.49.4	Application Number 10/673,940
	Applicant(s) Takehiro Nakamura, et al.	
	Filing Date 9/29/2003	Group Art Unit 2631

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

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FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
/K.K./	1	09-046311	2/14/1997	Japan	H04J3	00	✓	
/K.K./	2	05-091079	4/9/1993	Japan	H04J3	12	✓	
/K.K./	3	09-046275	2/14/1997	Japan	H04B3	04	✓	

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

/K.K./	4	Official Notice of Rejection Patent Application No.: 10-543752 Japan, 2005

EXAMINER <div style="text-align: center;">/Kevin Kim/</div>	DATE CONSIDERED <div style="text-align: center;">9/26/05</div>
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